The Kondo e ect in C₆₀ single-molecule transistors

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W e have used an electrom igration technique to fabricate C_{60} -based single-m olecule transistors. W e detail the process statistics and the protocols used to infer the successful form ation of a single-m olecule transistor. At low temperatures each transistor acts as a single-electron device in the C oulom b blockade regime. R esonances in the di erential conductance indicate vibrational excitations consistent with a known m ode of C $_{60}$. In several devices we observe conductance features characteristic of the K ondo e ect, a coherent m any-body state com prising an unpaired spin on the m olecule coupled by exchange to the conduction electrons of the leads. The inferred K ondo tem - perature typically exceeds 50 K, and signatures of the vibrational m odes persist into the K ondo regime.

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A transistor with an active region consisting of a single small molecule is the ultimate limit of the miniaturization of three-terminal electronic devices. Such single-molecule transistors (SM Ts) have been demonstrated using molecules of C₆₀ [1], C₁₄₀ [2], cobalt coordination complexes [3], and divanadium complexes [4]. These SM Ts function as single-electron transistors [5, 6], with conduction dominated by Coulom b blockade e ects. Because of the small size of the molecules, charging energies and single-particle level spacings in these devices are of the same order (1 eV), and are much larger than those in semiconductor or metal single-electron devices.

Devices incorporating the latter two molecules [3, 4]exhibit signatures of the Kondo e ect[7] in their conduction properties. In a single-electron device with a localized unpaired spin, it is possible to observe K ondo physics, the grow th of a correlated m any-body state com prising the localized spin interacting by antiferrom agetic exchange with the spins of the conduction electrons of the leads. This results in a Kondo resonance, an enhanced density of states of the leads. For dilute magnetic impurities in bulk metals the result is enhanced scattering and therefore a low temperature rise in the resistivity as the K ondo state develops. C onversely in single-electron devices [8, 9, 10, 11] the result is enhanced transmission, manifested as a zero bias peak in the conductance present when $T < T_K$, the K ondo tem perature. The K ondo energy scale T_K depends exponentially on the spin-lead coupling, and on the energy of the localized level relative to the Ferm i level of the lead conduction electrons. In single-electron devices, K ondo physics has been observed in sem iconductor quantum dots[12, 13], carbon nanotubes[14, 15], and the single-m olecule transistors incorporating m etalions m entioned above. K ondo tem peratures in these latter experim ents range from 10 K to 25 K .

In this letter, we report m easurem ents on SM T s incorporating individual C₆₀ m olecules coupled to gold source and drain electrodes. We describe the fabrication procedure in detail, including the statistics of the conduction properties of the resulting devices and the protocols used

to infer the successful form ation of a SMT.We conm the presence of C₆₀ vibrational resonances in devices in the C oulom b blockade regime. In several devices we report observations consistent with K ondo physics. The K ondo temperatures inferred from the transport data typically exceed 50 K, signi cantly higher than previously reported values in single-electron devices. The data also suggest that signatures of inelastic vibrational processes can persist well into the K ondo regime, evidence of coupling between a vibrational excitation and the coherent m any-body state.

The fabrication process is based on the electromigration technique[16] employed in previous SMT investigations[1, 2, 3, 4]. E-beam lithography (EBL) and lift-o processing are used to de ne 15-60 m etal constrictions connected to contact pads on degenerately doped p+ silicon substrates topped by 200 nm of therm al Si O_2 . An example of such a construction is shown in Fig. 1(a). The metal, 1 nm of Ti (0.1 nm/s) and 15 nm of Au (0.2 nm /s), is deposited in an e-beam evaporator with base pressure of 10 7 mB.A fter lifto the surface is cleaned by UV ozone for 5 m inutes and 0 $_2$ plasm a for 1 m inute. Then 80 L of C₆₀ in toluene solution $(1 \text{ mg C}_{60} / 1 \text{ mL toluene})$ are spin cast (spin 900 RPM) onto the array of junctions. Scanning speed tunneling m icroscopy (STM) in ages of C 60 deposited in this manner on an evaporated T i/A u Im show approxim ately m onolayer coverage of the m etal by the adsorbed molecules. An indium contact to the p+ silicon substrate, which serves as our back gate, is then m ade. The C_{60} decorated junctions are place in a variable tem perature vacuum probe station (Desert Cryogenics) for the electrom igration procedure and subsequent electrical characterization. The probe station is evacuated by turbomolecular pump (base pressure of probe station at 300 K is 5 10 5 mB) and cryopum ped by a carbon felt 'sorption pump therm ally anchored to the incom ing cryogen line.

A two-step variation of the electrom igration technique is employed to separate the constrictions into distinct source and drain electrodes. Using an HP

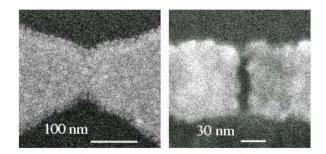


FIG.1: (a) Scanning electron in age of a 1 nm T i/15 nm Au constriction de ned by electron beam lithography on 200 nm SiD₂ on a degenerately doped p+ Si substrate (gate electrode). (b) A similar constriction after the electrom igration procedure described in the text. The resulting interelectrode gap is less than 2 nm in this case.

4145B sem iconductor parameter analyzer, at 300 K the voltage across each junction is ramped from 0 to 400 mV while monitoring the resulting current. W hen electrom igration-induced junction breaking begins, indicated by decreased junction conductance, the maximum voltage across the junction is reduced in steps of 40 m V until the junction resistance is increased to 400-1000 Once each junction is \partially broken," the sample is cooled to liquid helium temperatures. At 4.2 K the electrom igration process is continued, with the maximum voltage ramps across the junction increased in steps of 200 mV as the junction conductance decreases. This process is halted when the resistance of the resulting electrodes is > 100 k \cdot . This two-step electrom igration technique allows us to make relatively high conductance electrodes consistently, which we infer corresponds to a very small interelectrode gap. A courate scanning electron m icroscopy (SEM) assessment of the interelectrode gap is di cult because the new ly exposed m etal surfaces reconstruct when the electrodes are warm ed back to room tem perature. From SEM im ages of these resulting electrodes (Fig. 1 (b)), we can see that the separation is less than 2 nm, the resolution of the SEM . Since the diam eter of a C 60 m olecule is only 0.7 nm, closely spaced electrodes are essential for C $_{60}$ SM T s.

Due to the stochastic nature of the electrom igration process, every electrode pair di ers at the atom ic scale. Even if the closest interelectrode separation is the right size, the presence of a C_{60} m olecule at that location is probabilistic, and depends strongly on the initial surface coverage of C₆₀. If a molecule is present, its couplings to the source, drain, and gate electrodes are determ ined by the m icroscopic arrangem ent of the junction region, which is di erent in every device. We know of no atom ic-scale in aging technique at present that is capable of directly assessing in-situ the presence of an individualm olecule between source and drain electrodes and the morphology of the gold electrodes ad acent to the m olecule. Furtherm ore, the local charge environm ent of the SMT is unknown a priori due to the existence of surface trap states at the oxide surface. However, by analyzing m any samples statistically we can estim ate the percentage of the starting junctions that will become SM T given our fabrication procedure.

From a sample size of 1094 electrode pairs created using the above electrom igration procedure, including control samples (no molecules; di erent solvent exposures; di erent cleaning procedures), 70% show measurable source-drain currents after electrom igration at 4.2 K.W e have exam ined 475 junctions decorated with $\mathrm{C}_{\,60}$ and electrom igrated as described above. There are four classes of conductance characteristics in the resulting electrode pairs. (1) No detectable source-drain current at $y_{SD} = 0.1 V$ (34%). The simplest explanation of these devices is that the breaking procedure resulted in signi cantly too large a source-drain separation to permit conduction. (2) Linear or slightly superlinear I_D V_{SD} curves, consistent with simple tunneling behavior with therm ionic or eld em ission contributions at high bias (40%). The most likely explanation for these devices is that no molecule is present near the region of the source-drain gap that dom inates conduction. (3) Non-V_{SD} curves with steps and abrupt changes in trivialI_D slope, but no detectable dependence on gate voltage, V_G (15.3%). These devices likely have a molecule or metal nanoparticle at the critical region of the interelectrode gap, but local geom etry screens the object from the effects of the gate potential. (4) Nontrivial ID V_{SD} curves that may be tuned signi cantly by varying V_{c} (10.7%). Conduction in these devices may be examined as a function of V_{G} , V_{SD} , and T , and com pared with expectations for C oulom b blockade dom inated single-m olecule transistors. O ccasionally som e electrode pairs that initially have linear or nongateable $I_{D} \quad V_{SD} \ \ characteristics can \ change$ to exhibit interesting conductance features upon therm al cycling to 300 K and back to 4.2 K. Presum ably this is results from a combination of molecular rearrangem ent and m etal reconstruction at 300 K .

In a single-molecule transistor in the Coulomb blockade regime, the energetic cost of adding (removing) an electron to (from) the molecule, given by the Coulomb charging energy of the molecule and the energy di erence between molecular levels, is su ciently large, and the coupling between molecules and leads is su ciently poor, that at most gate voltages the average charge on the molecule is xed. The result of this charge quantization is a conductance gap, a region of V_{SD} near zero bias where the conductance is suppressed. The energetic alignment of the molecular orbitals with respect to the Ferm i levels of the source and drain electrodes is determ ined by: the work function of the metal; the electron a nity of the molecule; the presence of any nearby charged defects or traps; and the capacitive coupling to the gate electrode. Because of this gate coupling, the size of the conductance gap varies linearly and reversibly with V_G , since a more positive value of gate voltage makes it energetically favorable to add an electron to the molecule. At biases larger than the conductance gap, conduction is permitted because the source-drain potential di erence is su cient to overcome the electron addition (subtraction) energy. At certain values of gate voltage (charge degeneracy points), it becomes energetically degenerate for the charge of the molecule to change by one electron. The result is that the conductance gap vanishes at zero bias, and as V_G is increased through such a charge degeneracy point, the average number of electrons on the molecule is increased by one. Because of the extrem ely sm all size of the molecule, the C oulom b charging energy of the molecule and the single-particle level spacing are both large (>> 100 m eV).

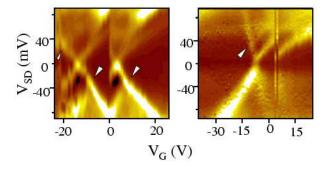


FIG.2: Color maps of the di erential conductance ($I_D = (V_{SD})$ as a function of gate and source-drain voltage, for two C₆₀ single-molecule transistors (black = 0 S; white (left) = 4 10⁶ S; white (right) = 12 10⁵ S, T = 42 K). The \resetting" of the V_G axis is due to uncontrolled changes in the molecular charge environment due to nearby traps in the oxide. Moving from left to right along the V_G axis across the charge degeneracy point changes the average charge on the molecule by one electron. The arrows indicate the 35 meV vibrational resonance previously reported in R ef. [1].

P revious investigations of single-m olecule transistors[1, 2, 3, 4] and other m olecular devices[17] have reported additional resonances in the di erential conductance at

nite bias, corresponding to excitations of m olecular vibrational modes during the transport process. For C_{60} devices[1], excitations of both the molecule-surface binding oscillation (5 m eV) and a mode intrinsic to the C $_{60}$ have been reported (35 m eV). To characterize the electronic conduction in a SMT at a xed tem perature, it is useful to plot the di erential conductance, $Q = QV_{SD}$, as a function of V_{SD} and V_G . The data shown here were acquired by measuring I_D as a function of V_{SD} for each value of V_G using the HP 4145B sem iconductor param eter analyzer. The di erential conductance is obtained by num erically di erentiation of this data, using Savitzky-Golay sm oothing to help reduce the noise in the resulting curves at the cost of V_{SD} resolution. For a given tem perature the resulting di erential conductance is plotted as a function of V_{SD} and V_{G} in a conductance contourm ap, where the color of the map represents di erent levels of conductance.

It is clear that not all gateable devices are C_{60} SM T s because about 5% of control sam ples (with no molecules) show some gateability. A pproximately half the gateable control sam ples have clear C oulom b blockade style transport features, and the signi cant majority of these are consistent (charging energy 30 m eV; many accessible charge states) with metal islands left behind following electromigration. The existence of these metal islands has been con med by SEM imaging. However, in two control devices on one substrate we observed C oulomb blockade features with charging energies as large as 400 m eV, though no apparent vibrational excited levels. It is conceivable that some unintended adsorbed molecules contaminated this particular set of devices during the preparation process.

W e have developed criteria for deciding if a particular device with nontrivial and gateable conductance is a SM T. The existence of Coulomb blockade is necessary but not su cient. The charging energy of the Coulom b blockade feature must be relatively large, > 100 m eV (This is a challenging experim ental requirem ent, because device stability can be poor at such large biases.). The num ber of accessible charge states should be reasonable, in light of solution-based electrochem ical redox information about the molecule. Finally, the existence of one or more vibrational resonances characteristic of the molecule (e.g. 35 meV for C₆₀) in the conductance map is the most indicative evidence that the device is a SMT. The conductance m aps of two devices m eeting these criteria are shown in Fig. 2. Note that the existence of surface trap states with charges that vary in time leads to instability in some devices. The random changes of the local charge environm ent near the tips of the electrodes contribute to some of the di culties we have in observing the 35 meV vibrational state. In some of devices there appear to be multiple Coulom b blockade features overlapping each other, possibly due to the presence of multiple molecules between the electrodes.

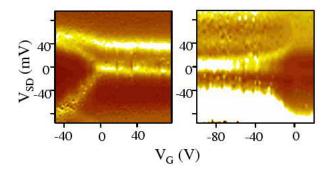


FIG.3: Conductance m aps for two devices showing apparent K ondo behavior, m an ifested as the appearance of a zero bias conductance peak in one m olecular charge state. Note the presence of 35 m eV sidebands persisting into the K ondo regime. (dark = 0 S; white (left) = $1.5 \quad 10^{-5} \text{ S}$; white (right) = $6 \quad 10^{-7} \text{ S}$; T = 4.2 K)

Four of the devices successfully electrom igrated at 4.2 K exhibit data like that shown in Fig. 3. When a transition is made from one charge state to another, a zero bias resonance appears in the di erential conductance. A lthough a zero bias resonance is occasionally seen in control samples, the feature is always gate independent. The transitional behavior from C oulom b blockade to zero bias resonance is never observed in devices made without C ₆₀ m olecules. This transition is consistent with the

K ondo e ect in single-electron devices, where the K ondo resonance can only exist when the active region of the device has an odd number of electrons.

W hen describing K ondo phenom ena in single-electron devices, the width of the localized state, , is de ned as the sum of the level widths due to the couplings, $_{\rm S}$; $_{\rm D}$ of the localized state to the source and drain, respectively. The energy di erence between the localized state (tunable by gate voltage) and the Ferm i level of the leads is . W hen 0 < = < 1, the system is said to be in the $\mbox{mixed-valence"}$ regim e, while = >> 1 corresponds to the K ondo regim e. In this limit, the K ondo tem perature is given [18, 19] by $T_{\rm K} = 0.5($ U $)^{l=2}$ exp(=).

Note that T_K depends exponentially on , and in a single-molecule transistor depends exponentially on the relative position of the molecule with respect to the leads. This steep dependence has made it extrem ely challenging to exam ine this physics over a large tem perature range, due to tem poral instability of the molecule-metal con guration. For example, in one device of the type shown in Fig. 3, while acquiring conductance data the device switched irreversibly from exhibiting a Kondo-like zero bias peak, as shown, to standard Coulom b blockade of the type shown in Fig. 2, without a change in the charge degeneracy point. Within the K ondo picture, this change corresponds to the molecule-lead coupling changing to lower T_K below T. We have been able to acquire data over a limited tem perature range for two devices exhibiting the K ondo-like resonance.

To analyze the zero bias resonance data in the context of K ondo physics, we follow previous SM T K ondo investigations [3, 4]. The K ondo tem perature m ay be inferred in two di erent ways. F irst, assuming spin-1/2, at xed gate voltage the zero bias conductance G m ay be monitored as a function of tem perature, and twith the form ula G (T) = $G_0 = (1 + 2^{1=s}T^2 = T_K^2)^s$, where G_0 is a constant and s 0.22 in the K ondo regime [19]. In both devices mentioned above, G (T) is nearly constant, decreasing only slightly from 4.2 K up to 30 K. This is consistent with large K ondo tem peratures, $T_K > 100$ K, though the data do not put an upper bound on T_K .

Further analysis is possible making use of the conductance maps. Consider the device shown in Fig. 4. The slopes of the Coulom b blockade gap edges approximately give, the conversion factor between gate voltage and the source-drain bias energy scale. For this sample,

2 m eV /V_G, not surprising given the 200 nm thickness of the gate oxide. As T ! 0, the width of the zero bias C oulom b blockade conductance peak as a function of gate voltage saturates to 32 m eV. U sing , and knowing that = 0 at the charge degeneracy point, we can nd (V). In a K ondo device the full-width at half m axim um of the zero bias conductance peak is expected to be β , 4, 12, 13, 14, 20] k_B T_K =e. Fig. 4 shows this FW HM as a function of = for that particular device. As with G (T), this data is, within the noise, nearly tem perature independent below 20 K, and an average of several low tem peratures is plotted. This FW HM increase as

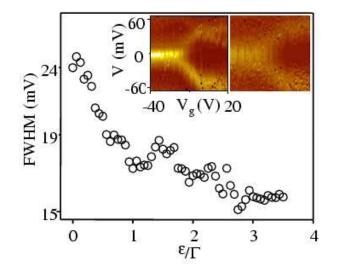


FIG.4: A plot of full-width at halfmaximum of the zero bias conductance peak as a function of = $/ J_{G} V_{c} j$ where V_{c} is the gate voltage of the charge degeneracy point. Inset: the conductance map of this device at 18 K (left) and 50 K (right), showing the persistance of the zero bias peak to quite high tem peratures (dark = 0 S; white = 1:15 10 ⁵ S).

! 0 is consistent with the K ondo behavior reported by Liang et al.[4]. The high e ective K ondo temperatures implied by this data are clear from the insets to Fig. 4, which demonstrate that the zero bias resonance is still visible up to at least 50 K.

O ther studies of the K ondo e ect in single-m olecule devices [3, 4] were able to demonstrate the Zeem an splitting of the K ondo resonance in an applied m agnetic eld. Because of the large intrinsic width (10-20 m eV) of the zero bias resonance (consistent with high K ondo tem peratures) that we observe, and the small size of the Zeem an splitting (115 eV per Tesla for a free electron), this would be extrem ely di cult to observe in our sam ples.

We also note that sidebands appear in these samples parallel to the zero bias peak. In the two samples shown in Fig. 3, the sidebands are located at V_{SD} 35 meV, and appear to evolve from the inelastic resonances ascribed to vibrational excitations during the tunneling process. Hints of this behavior were noted in Ref. [4], but here there is coincidence of the sideband voltage and the known molecular vibrational resonance. C onductance under these nonequilibrium conditions would involve some interplay between inelastic processes and the coherent m any-body K ondo state.

W e have successfully created C $_{60}$ -based single-m olecule transistors using the electrom igration technique[16]. Statistics on success are comparable to those reported by other investigators, and have been presented in detail, along with a discussion of controls and protocols. W e nd evidence of K ondo physics with large K ondo tem peratures in some of these SM T s without having a m etal ion present in the m olecule. A s m entioned above, sideband resonances indicate conduction processes that involve both m any-body correlations and inelastic coupling to vibrationalm odes. F inally, we note that a high tem perature K ondo resonance in C $_{60}$ adsorbed on a noble m etal electrodes would explain the surprisingly narrow local density of states observed in scanning tunneling m icroscopy experiments with C $_{60}$ tips[21].

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